



Attorney Docket No. 0756-7285

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/827,431

Filed: April 20, 2004

For: BEAM IRRADIATION APPARATUS,
BEAM IRRADIATION METHOD, AND
METHOD FOR MANUFACTURING
THIN FILM TRANSISTOR

) Group Art Unit:

) Examiner:

) CERTIFICATE OF MAILING

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Adeline M. Stanger

PRELIMINARY AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Drawings begin on page 2 of this paper and include an attached replacement sheets.

Remarks begin on page 3 of this paper.